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JUN 28 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Dkt. No.: 5545(2616-012)

Gene LEE et al.

Appln. No.: 10/039,333

Group Art Unit: 1765

Filed: November 9, 2001

Examiner: B. Tran

Title: Method for Etching Tungsten
Using NF_3 and Cl_2

OFFICIAL

**PETITION FOR EXTENSION OF TIME
UNDER 37 C.F.R § 1.136**

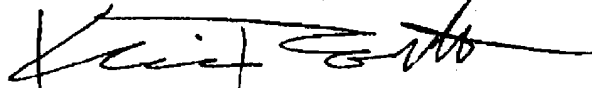
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby petitions for a one (1) month extension of time extending the period for reply to the Office Action mailed February 27, 2004 from May 27, 2004 to June 28, 2004 (June 27, 2004 falling on a Sunday). The Director of the U.S. Patent & Trademark Office is hereby authorized to charge the statutory fee of \$110.00 to Deposit Account No. 18-1579. The Director is also authorized to charge any fee deficiency, or credit any overpayment, to Deposit Account No. 18-1579.

Respectfully Submitted,

ROBERTS ABOKHAIR & MARDULA, LLC



Kevin L. PONTIUS
Reg. No. 37512
(505) 922-1400

Date: June 28, 2003

Atty. Dkt. No.: 5545 (2616-012)